



Dkt. No. 55220/844

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Shoji Miyazaki et al.

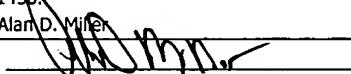
Appl. No. : 10/809,217

Filed : March 25, 2004

For : BIOSENSOR, THIN FILM ELECTRODE FORMING METHOD,
QUANTIFICATION APPARATUS, AND QUANTIFICATION
METHOD

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Examiner : Alexander Stephan Noguerola

**AMENDMENT AND SUPPLEMENTAL INFORMATION DISCLOSURE
STATEMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**

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Sir:

A Notice of Allowance issued in the above-identified application on February 22, 2010. The issue and publication fees have not yet been paid. Payment of the fees is due by May 24, 2010. Accordingly, this Request for Continued Examination (37 C.F.R. §1.114) and accompanying Amendment and Supplemental Information Disclosure Statement are being timely filed.